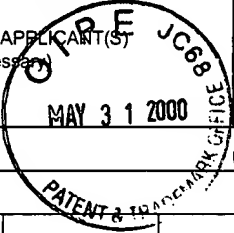


FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  Submitted to the PTO: May 31, 2000			ATTY DOCKET NO. <b>35.G2387</b>		APPLICATION NO. <b>09/309,766</b>		
			APPLICANTS <b>HIDEHIKO FUJIMURA, ET AL.</b>				
			FILING DATE <b>May 11, 1999</b>		GROUP <b>3729</b>		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KJA		4,045,849	09/1977	Thall	29	25.13	
KJA		5,681,198	10/1997	Peng, et al.	445	43	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
KJA		0 780 875	06/1997	Europe			
KJA		WO 98/26443	06/1998	PCT			
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			
<b>KENNETH J. RAMSEY</b> <b>PRIMARY EXAMINER</b>				<b>November 2000</b>			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

Submitted to the PTO: June 27, 2000

ATTY DOCKET NO.

**35.G2387**

APPLICATION NO.

**09/309,766**

APPLICANTS

**HIDEHIKO FUJIMURA, ET AL.**

FILING DATE

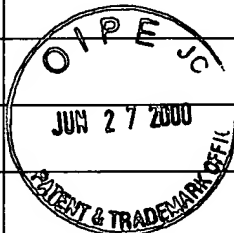
**May 11, 1999**

GROUP

**3729**

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE



## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
10/11	53-64461 ✓	06/1978	Japan	✓	✓	Yes
10/11	8-171871 ✓	07/1996	Japan	✓	✓	Yes
10/11	10-134721	05/1998	Japan	✓	✓	Yes
10/11	10-283930 ✓	10/1998	Japan	✓	✓	Yes

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)


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EXAMINER

**KENNETH J. RAMSEY**  
**PRIMARY EXAMINER**

DATE CONSIDERED

*November 2000*

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)  Submitted to the PTO: November 2, 1999			ATTY DOCKET NO. <b>35.G2387</b>		APPLICATION NO. <b>09/309,766</b>		
			APPLICANTS <b>HIDEHIKO FUJIMURA, ET AL.</b>				
			FILING DATE <b>May 11, 1999</b>		GROUP <b>Unassign d</b>		
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KJA		5,925,979	07/1999	Azuma, et al.	313	495	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
KJA		7-302545	11/1995	Japan			Abstract
KJA		7-296748	11/1995	Japan			Abstract
KJA		7-296731	11/1995	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
KJA		W.P. Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, pp. 90-185 (1956).					
KJA		C.A. Spindt, et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, Vol. 47, No. 12, pp. 5248-5263 (December 1976).					
KJA		C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, Vol. 32, No. 4, pp. 646-652 (April 1961).					
KJA		M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, No. 7, pp. 1290-1296 (July 1965).					
KJA		G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, Vol. 9, pp. 317-328 (1972).					
KJA		H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of Vacuum Society of Japan, Vol. 26, No. 1, pp. 22-29 (January 1983).					
KJA		M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devices Meeting, pp. 519-521 (1975).					
EXAMINER		KENNETH J. RAMSEY PRIMARY EXAMINER		DATE CONSIDERED November 2000			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 608; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1